

19903 U. S. PTO
09/842203
04/26/01

		Subclass	ISSUE CLASSIFICATION
	Class		

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
<i>A A</i> SCANNED <u>LM1</u> O.A. <i>all 1</i>	

CLASS	SUBCLASS		ART UNIT	EXAMINER
APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	
09/842203	F	430		1756

APPLICANTS

Maurits van der S
Irwan Setija
Everhardus Mos

三

Lithographic Projection apparatus, a method for determining a position of a substrate alignment mark, a device manufacturing method and device manufactured thereby

PTO-2040
12/99

ISSUING CLASSIFICATION

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.				NOTICE OF ALLOWANCE MAILED	
	_____ (Assistant Examiner) _____ (Date)				
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____ _____ _____				ISSUE FEE	
	_____ (Primary Examiner) _____ (Date)			Amount Due	Date Paid
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.				ISSUE BATCH NUMBER	
	_____ (Legal Instruments Examiner) _____ (Date)				

WARNING:

The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.

Form PTO-436A
(Rev. 6/99)

FILED WITH: DISK (CRF) FICHE CD-ROM
(Attached in pocket on right inside flap)